

Message Text

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21

ACTION EB-07

INFO OCT-01 CIAE-00 COME-00 DODE-00 NSAE-00 TRSE-00 EUR-12

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FM USMISSION OECD PARIS

TO SECSTATE WASH DC 7594

C O N F I D E N T I A L OECD PARIS 15847

EXCON

E.O. 11652 XGDS1

TAGS: ESTC, COCOM

SUBJECT: COCOM LIST REVIEW - 1355 - SEMICONDUCTOR MANU-
FACTURING MACHINERY

REF: OECD PARIS 15249

1. WE HAVE NOW POUCHED TO EWT AND OEA COPIES OF OUR
DRAFT TWG REPORT. REGULAR DISTRIBUTION THROUGH COCOM
SECRETARIAT WILL BE MADE ONCE WE HAVE CLEARANCES FROM
OTHER PARTICIPANTS.

2. INTERESTED AGENCIES WILL WANT TO TAKE ACCOUNT OF
FRENCH VIEWS THAT TERMS "AUTOMATIC" AND "SEMI-
AUTOMATIC" SHOULD BE CONSIDERED TO HAVE THE SAME MEAN-
INGS AS DEFINED IN NOTE TO IL 1358. UK HAS TOLD US, AS
REPORTED IN REFTEL, THAT THEY PREFER PRESENT WORDING TO
US COUNTERPROPOSAL, BUT LATTER'S ACCEPTABILITY TO THEM
WILL DEPEND ON EXTENT TO WHICH US CAN TAKE ACCOUNT OF
THEIR VIEWS, AS EXPRESSED IN TWG AND BEFORE, THAT BLOC
HAS CAPABILITY FOR MANY OF THE EQUIPMENTS LISTED IN US
PROPOSAL AND THAT APPROPRIATE SLICE SIZE LIMITATION IS
2 AND 1/2 INCHES RATHER THAN THE 2-INCH FIGURE IN US PRO-
POSAL. ISSUE OF APPARENT "RE-EMBARGOING" OF OTHERWISE
FREED TEST EQUIPMENT IS ALSO PROBABLE STICKING POINT
TO BOTH FRENCH AND UK.

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3. ACTION REQUESTED: EARLY INSTRUCTIONS TO CIRCULATE
FURTHER REVISION OF US PROPOSAL.
TURNER

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NNN

Message Attributes

Automatic Decaptioning: X
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Disposition Authority: GarlanWA
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Margaret P. Grafeld
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To: STATE
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